

# Jaegab Lee

## List of Publications by Year in descending order

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85  
papers

1,365  
citations

394421

19  
h-index

377865

34  
g-index

87  
all docs

87  
docs citations

87  
times ranked

1949  
citing authors

#	ARTICLE	IF	CITATIONS
1	Layer-by-layer assembled charge-trap memory devices with adjustable electronic properties. <i>Nature Nanotechnology</i> , 2007, 2, 790-795.	31.5	251
2	Tunable Memory Characteristics of Nanostructured, Nonvolatile Charge Trap Memory Devices Based on a Binary Mixture of Metal Nanoparticles as a Charge Trapping Layer. <i>Advanced Materials</i> , 2009, 21, 178-183.	21.0	97
3	Monte Carlo simulations of the structure of Pt-based bimetallic nanoparticles. <i>Acta Materialia</i> , 2012, 60, 4908-4916.	7.9	71
4	Fibertronic Organic Light-Emitting Diodes toward Fully Addressable, Environmentally Robust, Wearable Displays. <i>ACS Nano</i> , 2020, 14, 1133-1140.	14.6	60
5	Factors Affecting Passivation of Cu(Mg) Alloy Films. <i>Journal of the Electrochemical Society</i> , 2000, 147, 3066.	2.9	42
6	Nonvolatile nanocrystal charge trap flash memory devices using a micellar route to ordered arrays of cobalt nanocrystals. <i>Applied Physics Letters</i> , 2007, 91, 153506.	3.3	42
7	Plasmonically Engineered Textile Polymer Solar Cells for High-Performance, Wearable Photovoltaics. <i>ACS Applied Materials &amp; Interfaces</i> , 2019, 11, 20864-20872.	8.0	37
8	Niobium oxide nanoparticle core-amorphous carbon shell structure for fast reversible lithium storage. <i>Electrochimica Acta</i> , 2017, 240, 316-322.	5.2	34
9	Aminosilane SAM-Assisted Patterning of Poly(3,4-ethylenedioxythiophene) Nanofilm Robustly Adhered to SiO <sub>2</sub> Substrate. <i>Macromolecular Rapid Communications</i> , 2007, 28, 1574-1580.	3.9	29
10	Design of a MoO <sub>x</sub> /Au/MoO <sub>x</sub> transparent electrode for high-performance OLEDs. <i>Organic Electronics</i> , 2016, 36, 61-67.	2.6	29
11	Mobility Enhanced Photoactivity in Sol-Gel Grown Epitaxial Anatase TiO <sub>2</sub> Films. <i>Langmuir</i> , 2008, 24, 2695-2698.	3.5	26
12	ITO-free low-cost organic solar cells with highly conductive poly(3,4-ethylenedioxythiophene): p-toluene sulfonate anodes. <i>Solar Energy Materials and Solar Cells</i> , 2011, 95, 3573-3578.	6.2	26
13	Permanent optical doping of amorphous metal oxide semiconductors by deep ultraviolet irradiation at room temperature. <i>Applied Physics Letters</i> , 2010, 96, .	3.3	23
14	Effects of iron(III) p-toluenesulfonate hexahydrate oxidant on the growth of conductive poly(3,4-ethylenedioxythiophene) (PEDOT) nanofilms by vapor phase polymerization. <i>Synthetic Metals</i> , 2011, 161, 1347-1352.	3.9	23
15	The effects of the surface morphology of poly(3,4-ethylenedioxythiophene) electrodes on the growth of pentacene, and the electrical performance of the bottom contact pentacene transistor. <i>Solid-State Electronics</i> , 2012, 67, 70-73.	1.4	23
16	Electrochemical behavior of manganese oxides on flexible substrates for thin film supercapacitors. <i>Electrochimica Acta</i> , 2015, 153, 184-189.	5.2	22
17	Dry patterning of copper films using an O <sub>2</sub> plasma and hexafluoroacetylacetone. <i>Thin Solid Films</i> , 2001, 392, 122-127.	1.8	21
18	Effect of Mg content in Cu(Mg)/SiO <sub>2</sub> /Si multilayers on the resistivity after annealing in an oxygen ambient. <i>Journal of Vacuum Science and Technology A: Vacuum, Surfaces and Films</i> , 2000, 18, 2972-2977.	2.1	19

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19	Electrochemical lithium storage kinetics of self-organized nanochannel niobium oxide electrodes. <i>Journal of Electroanalytical Chemistry</i> , 2015, 746, 45-50.	3.8	19
20	Plasma pretreatment of the Cu seed layer surface in Cu electroplating. <i>Materials Chemistry and Physics</i> , 2002, 73, 227-234.	4.0	18
21	Effects of defects generated in ALD TiO <sub>2</sub> films on electrical properties and interfacial reaction in TiO <sub>2</sub> /SiO <sub>2</sub> /Si system upon annealing in vacuum. <i>Metals and Materials International</i> , 2008, 14, 759-765.	3.4	18
22	Selective deposition of TiSi <sub>2</sub> on oxide patterned wafers using low pressure chemical vapor deposition. <i>Journal of Electronic Materials</i> , 1991, 20, 331-337.	2.2	17
23	MOCVD of TiN and/or Ti from new precursors. <i>Thin Solid Films</i> , 1998, 320, 15-19.	1.8	17
24	Effects of ion damage on the surface of ITO films during plasma treatment. <i>Applied Surface Science</i> , 2007, 253, 8928-8932.	6.1	16
25	Aminosilane monolayer-assisted patterning of conductive poly(3,4-ethylenedioxythiophene) source/drain electrodes for bottom contact pentacene thin film transistors. <i>Organic Electronics</i> , 2010, 11, 338-343.	2.6	16
26	Strain Relaxation in Sol-gel Grown Epitaxial Anatase Thin Films. <i>Journal of Physical Chemistry C</i> , 2008, 112, 4205-4208.	3.1	15
27	MoO <sub>3</sub> /Au/MoO <sub>3</sub> /PEDOT:PSS multilayer electrodes for ITO-free organic solar cells. <i>Materials Science in Semiconductor Processing</i> , 2014, 27, 114-120.	4.0	15
28	Effects of Surface Oxide on the Nitridation Behavior of Aluminum Particles. <i>Metallurgical and Materials Transactions A: Physical Metallurgy and Materials Science</i> , 2015, 46, 496-504.	2.2	14
29	Effects of Solvents on Poly(3,4-Ethylenedioxythiophene) (PEDOT) Thin Films Deposited on a (3-Aminopropyl)Trimethoxysilane (APS) Monolayer by Vapor Phase Polymerization. <i>Electronic Materials Letters</i> , 2010, 6, 17-22.	2.2	13
30	Pulsed laser chemical vapor deposition of a mixture of W, WO <sub>2</sub> , and WO <sub>3</sub> from W(CO) <sub>6</sub> at atmospheric pressure. <i>Thin Solid Films</i> , 2017, 626, 145-153.	1.8	13
31	ITO free MoO <sub>3</sub> /Au/MoO <sub>3</sub> structures using Al <sub>2</sub> O <sub>3</sub> as protective barrier between MoO <sub>3</sub> and PEDOT:PSS in organic solar cells. <i>Renewable Energy</i> , 2014, 71, 193-199.	8.9	12
32	Self-assembled monolayer modified MoO <sub>3</sub> /Au/MoO <sub>3</sub> multilayer anodes for high performance OLEDs. <i>Electronic Materials Letters</i> , 2017, 13, 16-24.	2.2	12
33	Effect of Temperature on Coalescence Behavior of Unsupported Gold Nanoparticles. <i>Electronic Materials Letters</i> , 2019, 15, 133-139.	2.2	12
34	Significantly improved stability of n-octadecyltrichlorosilane self-assembled monolayer by plasma pretreatment on mica. <i>Thin Solid Films</i> , 2008, 516, 940-947.	1.8	11
35	High performance of pentacene organic thin film transistors by doping of iodine on source/drain regions. <i>Organic Electronics</i> , 2013, 14, 1142-1148.	2.6	11
36	Translated structural morphology of conductive polymer nanofilms synthesized by vapor phase polymerization. <i>Synthetic Metals</i> , 2018, 244, 113-119.	3.9	11

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37	Galvanically Replaced, Single-Bodied Lithium-Ion Battery Fabric Electrodes. <i>Advanced Functional Materials</i> , 2020, 30, 1908633.	14.9	11
38	Di- and tri-aminosilane SAM-assisted patterning of highly pure poly(3,4-ethylenedioxythiophene) nanofilms robustly adhered to silicon oxide substrate. <i>Surface and Coatings Technology</i> , 2007, 201, 9426-9431.	4.8	10
39	Design of gate stacks for improved program/erase speed, retention and process margin aiming next generation metal nanocrystal memories. <i>Semiconductor Science and Technology</i> , 2009, 24, 115009.	2.0	10
40	High Performance Flexible Organic Thin Film Transistors (OTFTs) with Octadecyltrichlorosilane/ $\text{Al}_2\text{O}_3$ /Poly(4-vinylphenol) Multilayer Insulators. <i>Journal of Nanoscience and Nanotechnology</i> , 2012, 12, 1348-1352.	0.9	10
41	PEDOT gate electrodes with PVP/ $\text{Al}_2\text{O}_3$ dielectrics for stable high-performance organic TFTs. <i>Electronic Materials Letters</i> , 2013, 9, 741-746.	2.2	10
42	Hybrid dielectric layer for low operating voltages of transparent and flexible organic complementary inverter. <i>Electronic Materials Letters</i> , 2015, 11, 252-258.	2.2	10
43	Semitransparent, thin metal grid-based hybrid electrodes for polymer solar cells. <i>Materials Science in Semiconductor Processing</i> , 2014, 23, 104-109.	4.0	9
44	Plasma Enhanced Chemical Vapor Deposition of Blanket $\text{TiSi}_2$ on Oxide Patterned Wafers: I. Growth of Silicide. <i>Journal of the Electrochemical Society</i> , 1992, 139, 1159-1165.	2.9	8
45	$\text{CH}_3\text{NH}_3\text{PbBr}_3$ nanocubes-array for solar cell application. <i>Materials Science in Semiconductor Processing</i> , 2018, 74, 361-368.	4.0	8
46	Plasma Enhanced Chemical Vapor Deposition of Blanket $\text{TiSi}_2$ on Oxide Patterned Wafers: II. Silicide Properties. <i>Journal of the Electrochemical Society</i> , 1992, 139, 1166-1170.	2.9	7
47	Significantly Improved Adhesion of Poly(3,4-ethylenedioxythiophene) Nanofilms to Amino-Silane Monolayer Pre-Patterned $\text{SiO}_2$ Surfaces. <i>Journal of Nanoscience and Nanotechnology</i> , 2007, 7, 3792-3794.	0.9	7
48	Effect of $\text{O}_2$ Gas during Inductively Coupled $\text{O}_2/\text{Cl}_2$ Plasma Etching of Mo and $\text{HfO}_2$ for Gate Stack Patterning. <i>Japanese Journal of Applied Physics</i> , 2008, 47, 6938-6942.	1.5	7
49	Formation of Cu nanocrystals on 3-mercaptopropyltrimethoxysilane monolayer by pulsed iodine-assisted chemical vapor deposition for nonvolatile memory applications. <i>Applied Physics Letters</i> , 2009, 94, 213508.	3.3	7
50	Effects of Si interlayer on resistance switching of Pt/Si/ $\text{TiO}_2$ /Pt structures. <i>Journal of Vacuum Science &amp; Technology B</i> , 2009, 27, 2175.	1.3	7
51	Enhanced Chemical Vapor Deposition of Pt Films on UV-exposed $\text{TiO}_2$ Surfaces. <i>Electronic Materials Letters</i> , 2009, 5, 35-38.	2.2	7
52	Indium Tin Oxide-Free PEDOT:PSS/SAM/ $\text{MoO}_3$ /SAM/Au/ $\text{MoO}_3$ /SAM Multilayer Electrodes for Organic Solar Cells. <i>Journal of Nanoscience and Nanotechnology</i> , 2014, 14, 7779-7783.	0.9	7
53	Mechanical and electrical stability of PEDOT:PTS and Au source/drain electrodes for bottom contact OTFTs on plastic films under bending conditions. <i>Organic Electronics</i> , 2015, 26, 8-14.	2.6	7
54	Tailoring methyl-ammonium lead bromide nanostructure by solvent engineering and their application to high open circuit voltage solar cells. <i>Physica E: Low-Dimensional Systems and Nanostructures</i> , 2021, 126, 114420.	2.7	7

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55	Selective Deposition of Copper with Iodine Assisted Growth of MOCVD on an MPTMS Monolayer Surface at a Low Temperature. <i>Electronic Materials Letters</i> , 2010, 6, 209-213.	2.2	6
56	Effects of Chlorine Contents on Perovskite Solar Cell Structure Formed on CdS Electron Transport Layer Probed by Rutherford Backscattering. <i>Electronic Materials Letters</i> , 2018, 14, 700-711.	2.2	6
57	Fabrication and optimization of nanocube mixed halide perovskite films for solar cell application. <i>Solar Energy</i> , 2020, 201, 209-218.	6.1	6
58	Structural and morphological features of concentric iron oxide/carbon nanotubes obtained from phospholipids. <i>Journal of Materials Chemistry</i> , 2010, 20, 5748.	6.7	5
59	Self-assembled nanolayers as interfacial diffusion barriers for thermally stable and low contact resistance Cu source/drain electrode in a-Si:H TFT-LCDs. <i>Electronic Materials Letters</i> , 2012, 8, 21-25.	2.2	5
60	ITO-free organic solar cell with an PEDOT:PTS/Au/TiO <sub>2</sub> grid hybrid electrode as a transparent anode. <i>Current Applied Physics</i> , 2015, 15, S2-S7.	2.4	5
61	Strategically Manipulated Polymer Solar Cells to Incorporate Plasmonically Enhanced Spectral Upconversion Backplane. <i>Advanced Optical Materials</i> , 2020, 8, 2000466.	7.3	5
62	High temperature cracking of tungsten polycide films on quartz substrate. <i>Thin Solid Films</i> , 2000, 370, 307-310.	1.8	4
63	Fabrication of an a-IGZO Thin Film Transistor Using Selective Deposition of Cobalt by the Self-Assembly Monolayer (SAM) Process. <i>Journal of Nanoscience and Nanotechnology</i> , 2011, 11, 787-790.	0.9	4
64	Effects of solvent on the formation of the MUA monolayer on Si and its diffusion barrier properties for Cu metallization. <i>Electronic Materials Letters</i> , 2014, 10, 671-678.	2.2	4
65	The formation of low temperature Cu <sub>3</sub> Si in Ag(Cu)/Si structure upon annealing and its effects on adhesion and resistivity. <i>Materials Research Society Symposia Proceedings</i> , 2003, 766, 3151.	0.1	4
66	Effects of interfacial layer-by-layer nanolayers on the stability of the Cu TSV: Diffusion barrier, adhesion, conformal coating, and mechanical property. <i>Materials Science in Semiconductor Processing</i> , 2018, 83, 33-41.	4.0	3
67	Effect of Ge doping on the electrical properties of amorphous Zn <sup>2+</sup> Sn <sup>2+</sup> O thin films. <i>Current Applied Physics</i> , 2020, 20, 1041-1048.	2.4	3
68	In situ electron-doping of MoS <sub>2</sub> thin films by embedded MoO <sub>x</sub> S <sub>y</sub> particles during chemical vapor deposition. <i>Journal of Materials Science</i> , 2021, 56, 2879-2886.	3.7	3
69	Effects of the PbBr <sub>2</sub> :PbI <sub>2</sub> Molar Ratio on the Formation of Lead Halide Thin Films, and the Ratio <sup>TM</sup> s Application for High Performance and Wide Bandgap Solar Cells. <i>Materials</i> , 2022, 15, 837.	2.9	3
70	Adhesion, passivation, and resistivity of a Ag(Mg) gate electrode for an amorphous silicon thin-film transistor. <i>Journal of Materials Research</i> , 2003, 18, 1441-1446.	2.6	2
71	Effects of an Al interlayer on the formation of Pt film on TiO <sub>2</sub> /Pt/Si structures. <i>Current Applied Physics</i> , 2011, 11, S111-S114.	2.4	2
72	Consecutive and Selective Chemical Vapor Deposition of Pt/Al Bilayer Electrodes for TiO <sub>2</sub> Resistive Switching Memory. <i>Japanese Journal of Applied Physics</i> , 2013, 52, 10MC08.	1.5	2

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73	A simple process based on NH <sub>2</sub> - and CH <sub>3</sub> -terminated monolayers for low contact resistance and adherent Au electrode in bottom-contact OTFTs. <i>Electronic Materials Letters</i> , 2016, 12, 197-204.	2.2	2
74	Synthesis of highly conductive cobalt thin films by LCVD at atmospheric pressure. <i>Materials Science in Semiconductor Processing</i> , 2017, 68, 245-251.	4.0	2
75	Pulsed MOCVD of Cu Seed Layer using a (H <sub>2</sub> )Cu(3,3-Dimethyl-1-Butene) Source Plus H <sub>2</sub> Reactant. <i>Materials Research Society Symposia Proceedings</i> , 2004, 812, F3.21.1.	0.1	1
76	Temperature Dependence of Bis(triisopropylsilylethynyl)-Pentacene Nanofilm Deposited on Octadecyltrichlorosilane Self Assembled Monolayer Surface as a Transistor Channel. <i>Journal of Nanoscience and Nanotechnology</i> , 2010, 10, 3489-3492.	0.9	1
77	A Novel Method for Patterning of Poly(3,4-ethylenedioxythiophene) Films Using UV Exposure-Activated Self-Assembled Monolayers. <i>Journal of Nanoscience and Nanotechnology</i> , 2012, 12, 1457-1460.	0.9	1
78	Improvement of On/Off Ratio in Solution-Processed Graphene-Zinc Oxide Resistive Switching Memory by Blending with Polystyrene. <i>Journal of Nanoscience and Nanotechnology</i> , 2016, 16, 12918-12922.	0.9	1
79	Microstructures, structural, optical, and photovoltaic characteristics of mixed halide perovskite nanowires. <i>Applied Physics A: Materials Science and Processing</i> , 2021, 127, 1.	2.3	1
80	Influence of Mg on Resistivity, Adhesion, Agglomeration of Ag(Mg)/SiO <sub>2</sub> /Si Multilayers. <i>Materials Research Society Symposia Proceedings</i> , 2001, 686, 1.	0.1	0
81	Controllable Feature Sizes of Highly Conductive Poly(3,4-Ethylenedioxythiophene) Nanofilms Patterned on SiO <sub>2</sub> Surface. <i>Journal of Nanoscience and Nanotechnology</i> , 2008, 8, 5080-5084.	0.9	0
82	Memory Effect of Low-Temperature Processed ZnO Thin-Film Transistors Having Metallic Nanoparticles as Charge Trapping Elements. <i>Journal of Nanoscience and Nanotechnology</i> , 2012, 12, 1344-1347.	0.9	0
83	Direct contact of indium tin oxide layer to Al(Ni) alloy electrodes for a-Si:H thin film transistors: Effects of Ni alloying on interfacial oxide growth and contact resistance. <i>Thin Solid Films</i> , 2013, 546, 9-13.	1.8	0
84	Dry Patterning of Cu(Mg) Alloy Films Using a Self-Aligned MgO Mask In an Oxygen Plasma Plus H <sub>2</sub> Chemistry. <i>Materials Research Society Symposia Proceedings</i> , 2002, 716, 11191.	0.1	0
85	Effects of defects generated in ALD TiO <sub>2</sub> films on electrical properties and interfacial reaction in TiO <sub>2</sub> /SiO <sub>2</sub> /Si system upon annealing in vacuum. <i>Metals and Materials International</i> , 2008, 14, 759-765.	3.4	0